

**Notice of References Cited**

Application/Control No.

09/351,544

Applicant(s)/Patent Under  
Reexamination  
CARNS ET AL.

Examiner

Paul E Brock II

Art Unit

2815

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,683,931	11-1997	Takahashi, Sanekatsu	430/312
	B	US-			
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	D	US-			
	E	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Bencher et al., "Dielectric Antireflective Coatings for DUV Lithography", Solid State Technology, Mar 97, Vol. 40, issue 3
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.